

<b>Notic of References Cited</b>	Application/Control No. 09/971,958		Applicant(s)/Patent Under Reexamination IGARASHI ET AL.	
	Examiner Tuan Quach		Art Unit 2814	Page 1 of 1

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	B	US-5,770,508	06-1998	Yeh et al.	438/3055
	C	US-5,817,562	10-1998	Chang et al.	438/305
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**NON-PATENT DOCUMENTS**

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	U	Wolf, S., et al., Silicon Processing, Vol. 1, 1986, Lattice Press, pp. 368-369.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.